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00862.022205.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshiyuki NAGAI et al.) : Examiner: M. Landau
Application No.: 09/839,139) : Group Art Unit: 2815
Filed: April 23, 2001) : Confirmation No.: 1616
For: LASER OSCILLATION APPARATUS, EXPOSURE) : Issue Fee Paid: August 30, 2004
APPARATUS, SEMICONDUCTOR DEVICE) :
MANUFACTURING METHOD, SEMICONDUCTOR) March 7, 2005
MANUFACTURING FACTORY, AND EXPOSURE) :
APPARATUS MAINTENANCE METHOD)

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THIRD REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Sir:

In response to the Corrected Filing Receipt mailed January 18, 2005, Applicants' attorneys request that another corrected Official Filing Receipt be issued in the above-identified application to make the following correction. The Corrected Filing Receipt dated January 18, 2005, omits the Assignee information. Specification, under the section entitled "Applicant(s)," please insert the following:

-- Assignment For Published Application

Canon Kabushiki Kaisha, Tokyo, JAPAN --.

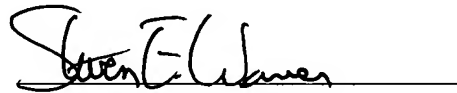
A copy of the Official Filing Receipt with the requested correction indicated in red is attached.

Applicants, therefore, request issuance of a corrected Official Filing Receipt corrected as shown above.

Applicants believe that no fees should be incurred in filing this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for filing this paper. A duplicate of this paper is attached for that purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address listed below.

Respectfully submitted,


Attorney for Applicants
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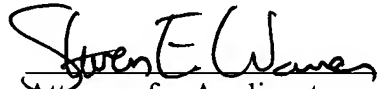
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| APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
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| 09/839,139 | 04/23/2001 | 2815 | 2154 | 862.C2205 | 11 | 24 | 6 |

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00862.022205 CORRECTED FILING RECEIPT

CONFIRMATION NO. 1616



OC00000001497460

Date Mailed: 01/18/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Yoshiyuki Nagai, Tochigi, JAPAN;
Naoto Sano, Tochigi, JAPAN;

Assignment For Published Patent Application
Canon Kabushiki Kaisha, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 05514.

Domestic Priority data as claimed by applicant

Foreign Applications

JAPAN 2000-126502 04/26/2000

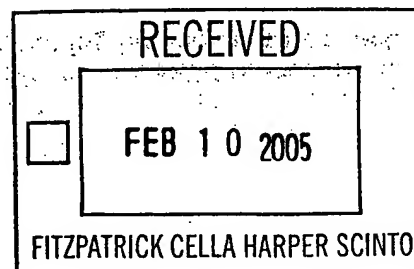
If Required, Foreign Filing License Granted: 06/13/2001

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US09/839,139**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No



Title

LASER OSCILLATION APPARATUS, EXPOSURE APPARATUS, SEMICONDUCTOR DEVICE
MANUFACTURING METHOD, SEMICONDUCTOR MANUFACTURING FACTORY, AND
EXPOSURE APPARATUS MAINTENANCE METHOD

Preliminary Class

372

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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